IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Landau

Serial No.: 10/622.001

Confirmation No : 2266

Filed:

July 17, 2003

For:

Flectro-Chemical

Deposition System Method of Electroplating on

Substrates

MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir

š š Group Art Unit: 1746 000000000000

Bruce F Rell Examiner:

CERTIFICATE OF MAILING OR TRANSMISSION.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner Bruce F, Bell, on the date shown below.

September 28, 2007 Steven H. VerSteeg

RESPONSE TO FINAL OFFICE ACTION DATED MAY 29, 2007

š

In response to the Final Office Action dated May 29, 2007, having a shortened statutory period for response extended to expire on September 29, 2007, please enter this response and reconsider the claims pending in the application for the reasons discussed below. A separate fee transmittal is attached hereto authorizing payment of a ONE-MONTH extension of time. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/002601.R2/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

The Pending Claims are reflected in the listing of claims which begins on page 2. of this paper. Remarks begin on page 16 of this paper.